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Re: Certification for Continental Automotive Systems US Inc.  
FCC ID: M3N385295  
IC: 7812A-385295

### REQUEST FOR CONFIDENTIALITY

Pursuant to USA FCC 47 CFR 0.457(d) and 0.459 and Canada IC RSP-100, Section 10, Continental Automotive Systems US Inc. requests that a part of the subject application be held confidential. Continental Automotive Systems US Inc. has spent substantial effort in developing this product and it is one of the first of its kind in industry. Having the subject information easily available to "competition" would negate the advantage they have achieved by developing this product. Not protecting the details of the design will result in financial hardship.

<u>Exhibit</u>	<u>Conf. Type</u>	<u>Rational</u>
Exh 04 - Block Diagram	<b>Permanent</b>	Includes proprietary internal oscillator frequency information.
Exh 05 - Schematics	<b>Permanent</b>	Includes proprietary design information
Exh 09 - Internal Photos	<b>Permanent</b>	DUT potted with non-removable epoxy
Exh 10 - BOM + Placement	<b>Permanent</b>	Includes proprietary design information
Exh 12 - Modes of Operation (part)	<b>Permanent</b>	Includes proprietary design information.

**Permanent Confidentiality:** Continental Automotive Systems US Inc. requests that any exhibits listed above as permanently confidential be permanently withheld from public review.

**Short-Term Confidentiality (FCC Only):** Continental Automotive Systems US Inc. requests that any exhibits selected above as short term confidential be withheld from public view for a period of days (noted above) from the date of the Grant of Equipment Authorization and prior to marketing.

If there are any questions regarding the application or testing performed, please contact us at the above address or call (734) 483-4211, or e-mail liepa@umich.edu.

Sincerely,

Valdis V. Liepa  
The University of Michigan Radiation Laboratory